IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Masaki HIRASE et al.

Serial Number: **NEW**

Filed: July 20, 2001

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Director of Patents and Trademarks Washington, D.C. 20231

July 20, 2001

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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Enclosures: PTO-1449; Reference (1).